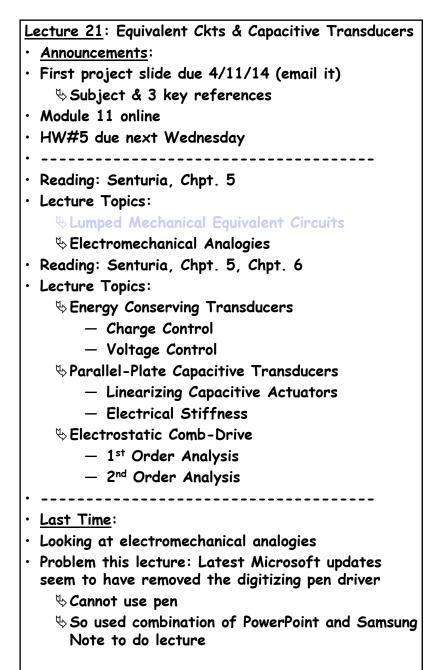
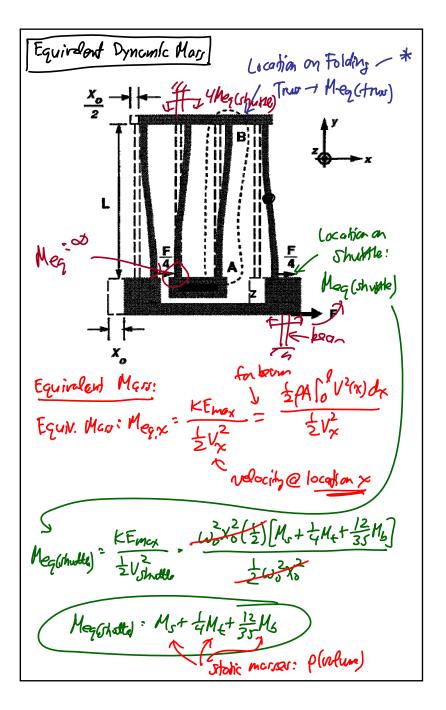
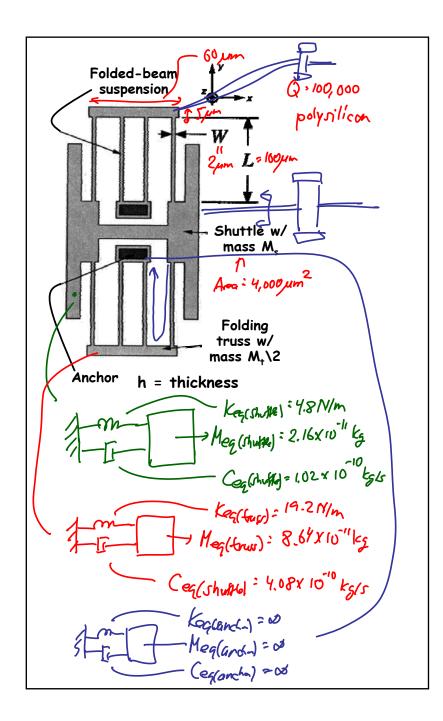
## <u>EE C245/ME C218</u>: Introduction to MEMS Design <u>Lecture 21w</u>: Equivalent Ckts. & Capacitive Transducers





### <u>EE C245/ME C218</u>: Introduction to MEMS Design <u>Lecture 21w</u>: Equivalent Ckts. & Capacitive Transducers

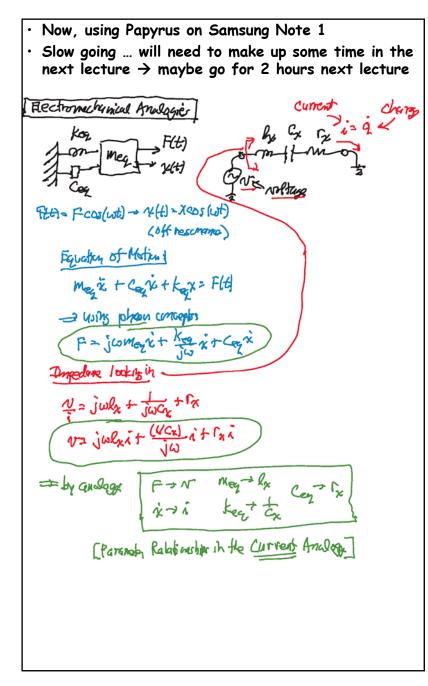
\*~  $Meg(twir) = \frac{\omega_{2}\chi_{2}^{2}(\frac{1}{2})[N_{r} + \frac{1}{2}M_{+} + \frac{1}{3}M_{b}]}{\frac{1}{2}(\frac{1}{2})\omega_{2}\chi_{0}^{2}}$ Meg(kaus) = 4 (Ms+ 4Me+ 12 Mb) equir. dynamic mars @ the truss localian Equir. Dynamic Stiffion) Wo: V Keg(x) - Keg(x) = Wo Meg(x) = large quit. man & large stiffer go hand-in-hand Equir. Dynamic Damping | Q = Wo Mag(x) ~ L Caq(x) - Caq(x) = Wo Maghy Kappy Maghxi A 2 R domping Keg(x) ) specified (@ single -m Meg(x) locition, X Ceq(x) - A Beg(x)

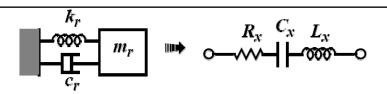


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# CTN 4/10/14

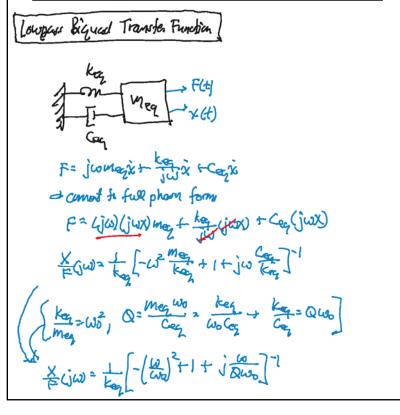
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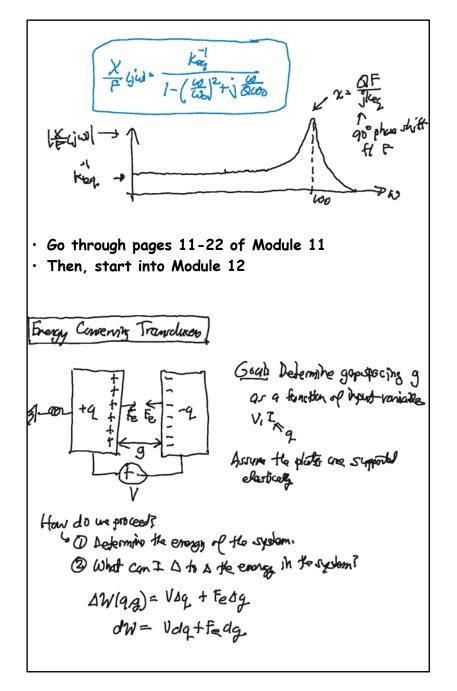


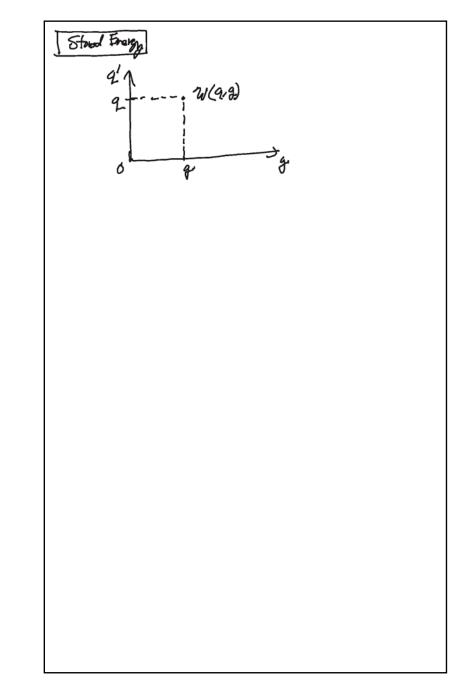
• Mechanical-to-electrical correspondence in the current analogy:

Mechanical Variable	Electrical Variable
Damping, c	Resistance, <i>R</i>
Stiffness <sup>-1</sup> , <i>k</i> <sup>-1</sup>	Capacitance, C
Mass, <i>m</i>	Inductance, <i>L</i>
Force, f	Voltage, V
Velocity, v	Current, I



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